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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**Applicants:** Jammy et al. **Examiner:** A. Ghyka  
**Serial No:** 09/594,638 **Group Art Unit:** 2812  
**Filed:** June 15, 2000 **Atty. Docket:** 99P7722US01(8055-98)  
**For:** METHOD FOR FORMING CRYSTALLINE SILICON NITRIDE

**BOX AF**

Assistant Commissioner for Patents  
Washington, D.C. 20231

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**RESPONSE TO FINAL OFFICE ACTION**

Sir:

This is a Response to the Final Office Action mailed on November 6, 2001.  
consider the following remarks.

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**CERTIFICATE OF MAILING 37 C.F.R. §1.8(a)**

I hereby certify that this correspondence (and any document referred to as being attached or enclosed) is being deposited with the United States Postal Service as first class mail, postage paid in an envelope addressed to: Assistant Commissioner for Patents, Box AF, Washington, D.C. 20231 on January 7, 2002.

Dated:

7 JAN 02

Juan C. Villar  
Juan C. Villar